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Confirmation Letter

To,
R.Gopi Reddy
Published in : Volume 3 | Issue 6 | 2016-06-08



Subject: Publication of paper at International Journal of Emerging Technologies and Innovative Research .

Dear Author,

With Greetings we are informing you that your paper has been successfully published in the International Journal of Emerging Technologies and Innovative Research (ISSN: 2349-5162). Following are the details regarding the published paper.

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Paper ID : JETIR1701650

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